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CONFIRMATION

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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *none*\*\* FOREIGN APPLICATIONS \*\*\*\*\* *18/1*

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no Met after Allowance Examiner's Signature _____ Initials _____	STATE OR COUNTRY GERMANY	SHEETS DRAWING 3	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 2
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## TITLE

Method and furnace for the vapor phase deposition of components onto semiconductor substrates with a variable main flow direction of the process gas

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